

<b>Notice of References Cited</b>	Application/Control No. 10/606,842		Applicant(s)/Patent Under Reexamination CHEN ET AL.	
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#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2003/0204656 A1	10-2003	Ha, Philip	710/301
	B	US-6,480,907 B1	11-2002	Chen et al.	710/15
	C	US-4,618,920	10-1986	Fox, David A.	363/37
	D	US-4,888,585	12-1989	Kamiya et al.	340/10.34
	E	US-2003/0073915 A1	04-2003	McLeod et al.	600/509
	F	US-2004/0268194 A1	12-2004	Kao et al.	714/724
	G	US-6,536,670 B1	03-2003	Postman et al.	235/487
	H	US-6,370,594 B1	04-2002	Chang et al.	710/3
	I	US-6,148,347 A	11-2000	Finch et al.	710/14
	J	US-6,064,721 A	05-2000	Mohammadian et al.	379/21
	K	US-5,818,029 A	10-1998	Thomson, Robert Bruce	235/486
	L	US-5,561,628 A	10-1996	Terada et al.	365/185.04
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
	W	
	X	

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